

À.



## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79467

Yuko YOSHIDA, et al.

Appln. No.: 10/761,258

Group Art Unit: 1754

Confirmation No.: 2566

Examiner: Unknown

Filed: January 22, 2004

For:

A METHOD FOR PRODUCING TITANIUM OXIDE

## INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §§ 1.97 and 1.98

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the duty of disclosure under 37 C.F.R. § 1.56, Applicant hereby notifies the U.S. Patent and Trademark Office of the document which is listed on the attached PTO/SB/08 A & B (modified) form and/or listed herein and which the Examiner may deem material to patentability of the claims of the above-identified application.

1. Lei et al., "Studies on Process Conditions of Preparing Nano-Titanium Dioxide with Homogenous Precipitation Method", *Inorganic Chemicals Industry*, Vol. 33, No. 2, March 2001, pp. 3-5, with English translation.

One copy of the listed document is submitted herewith.

The present Information Disclosure Statement is being filed: (1) No later than three months from the application's filing date; (2) Before the mailing date of the first Office Action on the merits (whichever is later); or (3) Before the mailing date of the first Office Action after

SAKATANI et al.

Appln. No. 10/456,746

Information Disclosure Statement

filing a request for continued examination (RCE) under §1.114, and therefore, no Statement

under 37 C.F.R. § 1.97(e) or fee under 37 C.F.R. § 1.17(p) is required.

A complete English translation of the foreign language document is being submitted

herewith, and therefore no concise explanation for such foreign language documents is required.

The submission of the listed document is not intended as an admission that any such

document constitutes prior art against the claims of the present application. Applicant does not

waive any right to take any action that would be appropriate to antedate or otherwise remove any

listed document as a competent reference against the claims of the present application.

The USPTO is directed and authorized to charge all required fees, except for the Issue

Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any

overpayments to said Deposit Account. A duplicate copy of this paper is attached.

Respectfully submitted,

Registration No. 32,607

SUGHRUE MION, PLLC

Telephone: (202) 293-7060

Facsimile: (202) 293-7860

WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: June 14, 2004

2

Substitute for Form 1449 A & B/PTO

INFORMATION DISCLOSURE
STATEMENT BY APPLICANT

Sheet

US US US

## Complete if Known Application Number 10/761,258 Confirmation Number 2566 Filing Date January 22, 2004 First Named Inventor Yuko YOSHIDA Art Unit 1754 Examiner Name Unknown

Q79467

(use as many sheets as necessary)

U.S. PATENT DOCUMENTS **Document Number** Cite **Publication Date** Examiner Kind Code<sup>2</sup> Name of Patentee or Applicant of Cited Document MM-DD-YYYY Initials\* No.1 Number (if known) US US US US US

Attorney Docket Number

FOREIGN PATENT DOCUMENTS									
Examiner Initials*	Cite No.1	Foreign Patent Document			Publication Date	Name of Patentee or			
		Country Code <sup>3</sup>	Number⁴	Kind Code <sup>5</sup> (if known)	MM-DD-YYYY	Applicant of Cited Document	Translation <sup>6</sup>		
		<b></b>				<del></del>			
			<del></del>						
	<del>.</del> .			1					

NON PATENT LITERATURE DOCUMENTS							
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.					
		Lei et al., "Studies on Process Conditions of Preparing Nano-Titanium Dioxide with Homogenous Precipitation Method", <i>Inorganic Chemicals Industry</i> , Vol. 33, No. 2, March 2001, pp. 3-5, with English translation					

	<del></del>	1		 
		1	i	
	1			
Evaninas Cianatura		Date Considered		
Examiner Signature		Date Considered		 

<sup>\*</sup>EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

<sup>&</sup>lt;sup>1</sup>Applicant's unique citation designation number (optional). <sup>2</sup>See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or follow the hyperlink from the title of the document to the intranet. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). <sup>4</sup>For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup>Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to indicate here if English language Translation is attached.